



**ELECTRONIC COPY**

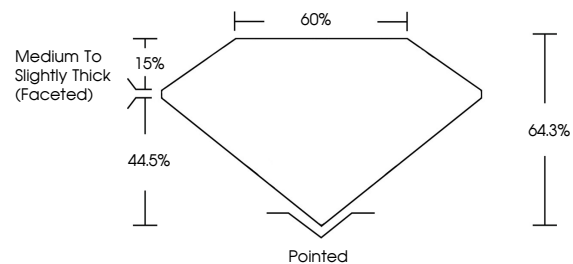
LG797627323  
Report verification at igi.org



April 30, 2026  
IGI Report Number **LG797627323**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PEAR BRILLIANT**  
Measurements **10.43 X 6.30 X 4.05 MM**  
**GRADING RESULTS**  
Carat Weight **1.53 CARAT**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

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**PROPORTIONS**

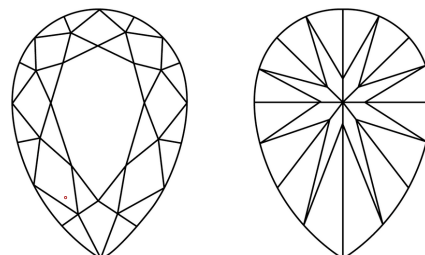


Sample Image Used

**GRADING RESULTS**

Carat Weight **1.53 CARAT**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

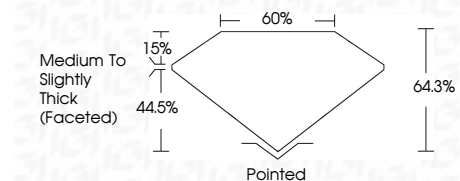
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG797627323**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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**IGI**



April 30, 2026  
IGI Report No. LG797627323  
PEAR BRILLIANT  
10.43 X 6.30 X 4.05 MM  
1.53 CARAT  
Color Grade F  
Clarity Grade VVS 2  
Depth 64.3%  
Table 60%  
Medium To Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscriptions(s) IGI LG797627323  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa